

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Kenichi Ishibashi et al.  
Serial No.: 10/543,050  
Confirmation No.: 2592  
Filed: December 12, 2005  
For: PHOTOELECTRIC CONVERSION ELEMENT AND PROCESS  
FOR FABRICATING THE SAME, ELECTRONIC APPARATUS  
AND PROCESS FOR FABRICATING THE SAME, AND  
SEMICONDUCTOR LAYER AND PROCESS FOR FORMING THE  
SAME  
Examiner: C. L. Novacek  
Art Unit: 2822

**Certificate of Electronic Filing Under 37 CFR 1.8**

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted via the Office electronic filing system in accordance with § 1.8(e)(4).

Dated: 6/16/10

Signature: Jen Leveille Jen Leveille,

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

In response to the Final Office Action dated March 16, 2010, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.